



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Toshinori NAKAYAMA

Group Art Unit: 2811

Application No.: 09/626,146

Examiner: O. Nadav

Filed: July 26, 2000

Docket No.: 106364

For: SUBSTRATE FOR SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR CHIP MOUNTING  
SUBSTRATE, SEMICONDUCTOR DEVICE AND  
METHOD OF FABRICATION THEREOF, AND  
CIRCUIT BOARD, TOGETHER WITH  
ELECTRONIC EQUIPMENT

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the submission filed December 18, 2003.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 151388 in the amount of ☒ \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

Kevin M. McKinley  
Registration No. 43,794

02/26/2004 JADD01 00000029 09626146

02 FC:1801

770.00 OP

JAO:KMM/cfr

Date: February 24, 2004

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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